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Sheet

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of

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•	Complete if Known		
Application Number	10/653,035		
Filing Date	August 29, 2003		
First Named Inventor	Scott a. Chambers		
Group Art Unit		_	
Examiner Name		_	
Attornev Docket Number	50005-153		

,	U.S. PATENT DOCUMENTS						
Examiner Cite No.1		Document Number Number-Kind Code ² (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear		
8		US 5,450,812	09/1995	McKee et al			
		US 5,362,711	11/1994	Takada et al.			
		US 5,695,863	12/1997	Bloemen et al.			
	•	US 5,448,084	09/1995	Hoke et al.	:		
M۵		US 5,350,737	09/1994	Harada et al.			
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Cite	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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	No.1		Publication Date	Application of Cited	No. Application of Cited Relevant Passages or Relevant

Examiner Signature	Matt	Date Considered	8/17/05

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¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the emperor must precede the serial number of the patent document. ³ Kind of document by the apOpropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO				Complete if Known		
			•	Application Number	10/653,035	
INFORMATION DISCLOSURE				Filing Date	August 29, 2003	
STATEMENT BY APPLICANT			PLICANT	First Named Inventor	Scott A. Chambers	
				Group Art Unit		
(use as many sheets as necessary)			ecessary)	Examiner Name		
Sheet	2	of	2	Attorney Docket Number	50005-153	
					<u> </u>	

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. ¹	include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	T ²
M		Lind et al., Growth and structual characterization of Fe304 and MiO Thin Films, Phys. Rev. B 45 (4) 1838-1850, 15 January 1992	
		Chambers, S. A., Epitaxial growth and properties of thin film oxides, Surf. Sci. Rep. 39, 2000 Elsevier Science B. V., 105-180	
		Suzuki et al., Structure and magnetic properties of epitaxial spinel ferrite thin films, (1) (Appl. Phys. Lett. 68 (5) 714-716, 29 January 1996)	
		Suzuki et al., <u>Magnetic anisotropy of epitaxial cobalt ferrite thin films</u> , (2) (J. of Magnetism and Magnetic Materials 191 (1999) 1-8	
\		Hu et al., Structural tuning of the magnetic behavior in spinel-structure ferrite thin films, (Phys. Rev. B62 (2) R779-782, 1 July 2000)	
MO		C. Lu, Y. Guan, Improved method of nonintrusive deposition rate monitoring by atomic absorptionJ. Vac. Sci. Technol. A13 (3) 1797-1801, May/Jun 1995	
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